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Bib Data Sheet

CONFIRMATION NO. 8851

SERIAL NUMBER 09/699,466	FILING DATE 10/31/2000 RULE	CLASS 438	GROUP ART UNIT 2829	ATTORNEY DOCKET NO. 0756-2222
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APPLICANTS

Shunpei Yamazaki, Tokyo, JAPAN;

Satoshi Teramoto, Kanagawa, JAPAN;
 Jun Koyama, Kanagawa, JAPAN; Yasushi Ogata, Kanagawa, JAPAN;
 Masahiko Hayakawa, Kanagawa, JAPAN;
 Mitsuaki Osame, Kanagawa, JAPAN;

** CONTINUING DATA ***** Yes AICS

This application is a DIV of 08/784,290 01/16/1997 PAT 6,180,439

** FOREIGN APPLICATIONS ***** Yes AICS

JAPAN 8-32874 01/26/1996

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/03/2001

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 25	INDEPENDENT CLAIMS 6
Verified and Acknowledged As Su Kumar Sarkar Examiner's Signature	Initials				

ADDRESS

31780
 ERIC ROBINSON
 PMB 955
 21010 SOUTHBANK ST.
 POTOMAC FALLS , VA
 20165

TITLE

METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance	JAPAN	7	25	6

ADDRESS

31780

TITLE

Method for fabricating a semiconductor device

FILING FEE RECEIVED	1454	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (F) <input type="checkbox"/> 1.17 Fees (I time) <input type="checkbox"/> 1.18 Fees <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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